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Bib Data Sheet

CONFIRMATION NO. 8827

<b>SERIAL NUMBER</b> 09/842,631	<b>FILING DATE</b> 04/27/2001 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2815	<b>ATTORNEY DOCKET NO.</b> 925-192
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**APPLICANTS**  
Wendong Zhen, Tenri-shi, JAPAN;

**\*\* CONTINUING DATA \*\***  
New IP

**\*\* FOREIGN APPLICATIONS \*\***  
JAPAN 2000-129690 04/28/2000  
JAPAN 2000-283481 09/19/2000  
JAPAN 2001-028606 02/05/2001

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* 06/19/2001**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 7	<b>TOTAL CLAIMS</b> 28	<b>INDEPENDENT CLAIMS</b> 6
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance				
Verified and Acknowledged Examiner's Signature: [Signature] Initials: [Initials]				

**ADDRESS**  
NIXON & VANDERHYE P.C.  
8th Floor  
1100 North Glebe Road  
Arlington, VA 22201-4714

**TITLE**  
Semiconductor device having ferroelectric thin film and fabricating method therefor

<b>FILING FEE RECEIVED</b> 1382	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
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